Study of electronic noise with a CsI(Tl) crystal

P.Gauzzi Roma1 EMC group

Experimental setup

- Aims of this test: study the effect of the FEE integration and shaping time on the crystal performance, in particular evaluate the electronic noise
- Crystal readout on one side by an APD (operated at HV = 340 V) wih the complete FEE chain: CSP + shaper
 PMT on the other side for trigger



APD signal

- Events acquired by a LeCroy digital oscilloscope (12 bits)
- Waveforms recorded at a sampling rate of 20GS/s
 - ~ 50000 events / measurement



• The shaper is sensitive to the amplitude \Rightarrow APD signal = maximum amplitude for T > 6000

Configurations studied

CSP Cremat integr. time = 140 μs + shaping time = 500 ns
 CSP Hamamatsu integr.time = 100 ns + shaping time = 100 ns
 CSP Hamamatsu integr.time = 100 ns + shaping time = 500 ns



Averages over 50000 waveforms

Noise expectations

• BTF test with LYSO crystal readout by APD with Cremat CSP

⇒ electronic noise was ~ 250 keV

• Assuming that the noise comes essentially from the shaper:

$$\frac{Noise(CsI)}{Noise(BTF)} = \frac{LY_{LYSO}}{LY_{CsI}} \frac{G_{APD}(380 \ V)}{G_{APD}(340 \ V)} Atten_{BTF} \frac{S(CsI)}{S(LYSO)} =$$
$$= \frac{75}{140} \times 4 \times 0.175 \times \frac{36}{4} \simeq 3.5$$

- The ratio S(CsI)/S(LYSO) takes into account the reduction from the crystal to the APD area (is the ratio between the surfaces of the crystals)
- We expect for the CsI(Tl) crystal with Cremat CSP: 0.25 × 3.5 ≈ 1 MeV P.Gauzzi

PMT energy calibration





• Int. time = 140 μ s; shaping time = 500 ns

- No data with ⁶⁰Co source, only with ¹³⁷Cs
- Check of the PMT energy scale: ¹³⁷Cs peak ⇒ 672 keV (662 keV nominal)
- We use the PMT signal to calibrate the APD response







Cremat – check with cosmics





Hamamatsu CSP

• Int. time = 100 ns; shaping time = 100 ns





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01 0.02 0.03 0.04 0.05

Hamamatsu CSP (s.t.=100 ns)



Hamamatsu CSP (s.t.=100 ns)





Int. time = 100 ns; shaping time = 500 ns



Hamamatsu CSP (s.t.=500 ns)





0.01 0.02 0.03 0.04



ampl_apd300ns4



ampl apd300ns2

Entries 499 Mean 0.0026 RMS 0.0043

499



Hamamatsu CSP (s.t.=500 ns)



Conclusions

- We tested a CsI(Tl) crystal readout by an APD in three different configurations:
 - 1) CSP Cremat integr. time = $140 \ \mu s$ + shaping time = $500 \ ns$
 - 2) CSP Hamamatsu integr.time = 100 ns + shaping time = 100 ns
 - 3) CSP Hamamatsu integr.time = 100 ns + shaping time = 500 ns
- With radioactive sources (⁶⁰Co and ¹³⁷Cs) we calibrate the energy scale
- We evaluate the electronic noise from the difference of the APD and PMT signals

configuration	σ(APD-PMT)
Cremat	1.6 MeV
Hamamatsu (s.t.=100 ns)	4 MeV
Hamamatsu (s.t.= 500 ns)	1.5 MeV

- We plan to test other configurations (e.g. Hamamatsu CSP with s.t.=250 ns)
- We also want to perform other checks with cosmics, but we have to understand the PMT saturation

CsI - waveform

